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) Art Unit: 1112

) Examiner: Padgett

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In re PATENT application of

Hisato Shinohara

Serial No. 08/169,127/

Filed: December 20, 1993

For: METHOD AND SYSTEM OF

LASER PROCESSING

AMENDMENT

Honorable Commissioner of Patents and Trademarks

Washington, D.C. 20231

Sir:

In response to the Office Action mailed January 3, 1995, please amend the above-identified application as follows:

In the Title:

Please change the title from "METHOD AND SYSTEM OF LASER PROCESSING" to -- METHOD OF PRODUCING THIN FILM PATTERNS USING A LASER --.

In the Claims:

Please amend claims 1, 6, and 11 as follows:

1. (Amended) A method for treating an object with a laser

comprising the steps of:

emitting a laser beam from [a] the laser;

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